



PATENT Attorney Docket No. 2887.0270

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	
TADASHI MITSUI	) Group Art Unit: 2621
Application No.: 10/807,187	) Examiner: Unknown
Filed: March 24, 2004	) Confirmation No.: 3737
For: PATTERN MEASURING APPARATUS, PATTERN MEASURING METHOD, AND MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE	) ) ) )
Commissioner for Patents	

P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

## **INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. § 1.97(b)**

Pursuant to 37 C.F.R. §§ 1.56 and 1.97(b), Applicant brings to the attention of the Examiner the document on the attached listing. This Information Disclosure Statement is being filed before the mailing date of a first Office Action on the merits for the above-referenced application.

A copy of the listed foreign document is attached.

Applicant respectfully requests that the Examiner consider the listed document and indicate that it was considered by making an appropriate notation on the attached form.

Applicant provides an English-language abstract of the listed foreign document.

This submission does not represent that a search has been made or that no better art exists and does not constitute an admission that listed document is material or constitutes "prior art." If the Examiner applies the document as prior art against any claim in the application and Applicant determines that the cited document does not constitute "prior art" under United States law, Applicant reserves the right to present to the office the relevant facts and law regarding the appropriate status of the document.

Applicant further reserves the right to take appropriate action to establish the patentability of the disclosed invention over the listed document, should the document be applied against the claims of the present application.

If there is any fee due in connection with the filing of this Statement, please charge the fee to Deposit Account 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW, GARRETT & DUNNER, L.L.P.

Dated:

y: ///

Reg. No. 31,744

IDS	Form	PTO/SB/08:	Substitute for	form	1449A/PTO
			O DO DICTION		1440701 10

## **INFORMATION DISCLOSURE** STATEMENT BY APPLICANT

(Use as many sneets as necessary)				
Sheet	1	of	1	

	/
Complete if Known	FFR 0 9 200
10/807,187	150 0 0 500
March 24, 2004	13
Tadashi Mitsui	70
2621	MADE
Unknown	
r 2887.0270	
	10/807,187  March 24, 2004  Tadashi Mitsui  2621  Unknown

U.S. PATENTS AND PUBLISHED U.S. PATENT APPLICATIONS						
Examiner	Cite	Document Number	Issue or Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where	
Initials	No. <sup>1</sup>	Number-Kind Code <sup>2</sup> (if known)			Relevant Passages or Relevant Figures Appear	
		US-				
		US-				
		US-				
	-	US-				
-		US-				
		US-				
		US-				
		US-				
		US-				
		US-				
		US-				

Note: Submission of copies of U.S. Patents and published U.S. Patent Applications is not required.

FOREIGN PATENT DOCUMENTS						
Examiner Initials	Cite No. <sup>1</sup>	Foreign Patent Document  Country Code <sup>3</sup> Number <sup>4</sup> Kind Code <sup>5</sup> ( <i>if known</i> )	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	Translation <sup>6</sup>
		JP 2003-178314	06-27-2003	Toshiba Corp.		Abstract

NONPATENT LITERATURE DOCUMENTS				
Examiner Initials	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	Translation <sup>6</sup>	

Examiner	Date	
Signature	Considered	

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.